



504-9925

# U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM 10001333	FILING DATE 10/26/2001	CLASS 427 250	SUBCLASS 595	GAU 288+	EXAMINER Mceks
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\*\*APPLICANTS: Kaito Takashi;

\*\*CONTINUING DATA VERIFIED:

*Abu Name*

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\*\* FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-333368 10/31/2000

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no

35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

S004-4433

TITLE : Beam shaped film pattern formation method

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	
		Print Claim for O.G.	
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> <b>TERMINAL</b>		<b>Application Examiner</b>	
<b>DISCLAIMER</b>		<b>PREPARED FOR ISSUE</b>	
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